

DOCKET NO: 214144US8



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
NAOKI TSUKIJI ET AL. : EXAMINER: SCHILLINGER, LAURA M.
SERIAL NO: 10/014,507 :
FILED: DECEMBER 14, 2001 : GROUP ART UNIT: 2813
FOR: METHOD OF MANUFACTURING SEMICONDUCTOR ELEMENT, AND
SEMICONDUCTOR ELEMENT MANUFACTURED WITH THIS METHOD

AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated September 8, 2003, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 11 of this paper.

RECEIVED
JAN 15 2004
TECHNOLOGY CENTER 2800

01/09/2004 YPOLITE1 00000116 10014507

01 FC:1202

36.00 DP